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\*\* FOREIGN APPLICATIONS \*\*\*\*\*  
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Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <i>Allowance</i> <input type="checkbox"/> no <i>Met after</i>	STATE OR COUNTRY JAPAN	SHEETS DRAWING 6	TOTAL CLAIMS 13	INDEPENDENT CLAIMS 4
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Verified and Acknowledged  
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 23911  
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TITLE  
 LSI device etching method and apparatus thereof

<input type="checkbox"/> All Fees
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